



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79882

Yasuaki TSUCHIYA, et al.

Appln. No.: 10/777,089

Group Art Unit: 1755

Confirmation No.: 4112

Examiner: Michael A. MARCHESCHI

Filed: February 13, 2004

For: CHEMICAL MECHANICAL POLISHING SLURRY

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 9, 2005, please amend the above-identified application as follows on the accompanying pages. A Petition for a one month extension of time is being concurrently filed making a response timely by September 9, 2005.

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